

Direct growth of metallic single-metal-atom chains

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Abstract:

Single-metal-atom chains (SMACs), as the smallest one-dimensional structure, have intriguing physical and chemical properties. Although several SMACs have been realized to date, their controllable fabrication remains challenging, because of the need to arrange single atoms in an atomically precise manner. Here, we develop a chemical vapour co-deposition method to construct a wafer-scale network of Pt SMACs in atom-thin films. The obtained atomic chains possess an average length of up to ~ 17 nm and a high density of over 10 wt%. Interestingly, as a consequence of the electronic delocalization of Pt atoms along the chain, this atomically coherent one-dimensional channel delivers a metallic behaviour, as revealed by electronic measurements, first-principles calculations, and complex network modelling. Our strategy is potentially extendable to other transition metals, e.g., Co, enriching the toolbox for manufacturing SMACs and paving the way for the fundamental study of one-dimensional systems and the development of monoatomic chain devices.

Introduction: Single-metal-atom chains (SMACs), known as one of the smallest one-dimensional structures, have garnered broad research interest, attributing to their unique properties, such as quantized conductance, thermal transport, charge/spin density waves, and peculiar magnetic properties, as well as distinct catalytic properties.¹⁻⁶ For example, it was reported that the average bond strength in the chain is twice that of the bulk counterpart⁷. Up to now, several SMACs like Au, Ir, and Pt chains have been fabricated by using a top-down mechanical break junction (MBJ) method, showing quantum ballistic transport^{8, 9}, anisotropic magnetoresistance^{10, 11}, and the Kondo effect¹². Alternatively, an ultra-high vacuum (UHV) self-assembly approach on the ultra-clean substrate was developed for preparing Au SMACs on Si, and Ge stepped surfaces¹³⁻¹⁵, serving as a 1D model system to study Peierls instabilities and Tomonaga–Luttinger liquid. Unfortunately, these methods require harsh growth conditions. Besides, the MBJ-SMACs suffer from low consecution (< 5 atoms length) and structural fragility, whereas self-assembled atom wires are extremely unstable under the atmosphere. These characteristics significantly restrict the broad applicability of resultant SMACs, particularly in devices¹⁶. Therefore, exploring a simple and efficient strategy for the scalable synthesis of SMACs with ambient atmosphere stability is still highly demanded to date.

Inspired by the formation mechanism of the 1D grain-boundary (GB) channel in 2D materials¹⁷⁻²⁰, we here report the fabrication of Pt SMACs network within the transition-metal dichalcogenide material (TMDC) film at a wafer scale (5 centimetres). The mirror-twin grain-boundary (MTB) acts as an ideal 1D host for Pt atoms, and the obtained Pt SMACs possess an average length of up to 17 nm and remarkable ambient air stability. We further demonstrate that these Pt SMACs are highly metallic, forming a network conduction pathway in the 2D film to enrich their electronic properties and functionalities. Moreover, we have also embedded Co

SMACs into MTBs of the MoS₂ film, suggesting the generalizability of our strategy for wafer-scale production of ambient air-stable SMACs.

Results and discussion

Synthesis and characterization of Pt SMACs. A chemical vapor co-deposition method was developed to fabricate Pt SMACs network in a wafer-scale atomically thin MoS₂ film (Fig. 1a) (see Methods for details). Ultra-small Pt nanoclusters (0.5-2 nm) were pre-deposited on SiO₂/Si substrate through e-beam evaporation, followed by the growth of MoS₂. This pre-deposited Pt layer plays two crucial roles in forming Pt SMACs: (i) serving as nucleation sites to induce the formation of GB-rich MoS₂ film (Fig. 1b). Highly dense Pt nanoclusters with an average spacing down to a few nanometers can be obtained by using low-rate evaporation (0.1 \AA s^{-1}) in our experiment (Supplementary Fig. 1-2). It enables the growth of high-density MoS₂ nanograins that provide abundant 1D channels for the Pt atom incorporation (Supplementary Fig. 8); (ii) supplying Pt to form Pt SMACs. As shown in Fig. 1e, these ultra-small Pt nanoclusters tend to become a liquid phase at the growth temperature of MoS₂ (600-750°C)²¹. Such liquid nanodroplets facilitate the diffusion of Pt atoms, which are further captured by MoS₂ domains to form thermodynamically stable structures. In short, Pt nanoclusters drive the growth of the GB-rich MoS₂ film. These dense GBs provide anchor sites for mobile Pt atoms, yielding single-atom-chain structures. Fig. 1b presents as-grown Pt SMACs in wafer-scale MoS₂ film from macroscopic to atomic views.

Next, we used X-ray photoelectron spectroscopy (XPS) and Raman spectroscopy to investigate the bonding states and the detailed structure of Pt SMACs. As shown in Fig. 1c, two sets of Pt(II) peaks can be clearly observed in the Pt 4f region, which correspond to two kinds of Pt(II) in different chemical environments. The absence of metallic Pt peaks indicates that all Pt

atoms are covalently bonded with S atoms instead of being physically adsorbed on the MoS₂ surface nor isolated as particles. Furthermore, large-area XPS analysis reveals an average Pt mass loading as high as ~13 wt%, implying a high density of SMACs achieved by this method. Notably, the mass loading achieved in our work is much higher than that of atomically dispersed Pt atoms (~5 wt%) in other works. Fig. 1d presents the Raman spectra of as-grown films. Given that the in-plane to out-of-plane mode ratio is a widely adopted metric to evaluate the crystallinity of MoS₂, our sample has a much smaller intensity ratio (0.28) than currently reported CVD-grown (~1.89) and physically exfoliated (~1.57) samples (Supplementary Table 1), suggesting a polycrystalline nature with high-density GBs. After examining tens of regions, we hardly observe peaks associated with PtS₂ or PtS, thus confirming that most Pt atoms are covalently bonded with S atoms at MoS₂ MTB instead of forming PtS₂ or PtS particles, which also agrees with the above XPS results.

We then examined the atomic structure of Pt SMACs in the monolayer MoS₂ film using annular dark-field scanning transmission electron microscopy (ADF-STEM) imaging, wherein Pt atoms with a high Z-contrast could be clearly identified (Fig. 2a). The corresponding fast-Fourier transformation pattern (viewing from the zone axis of <001> in the inset of Fig. 2a) presents a diffraction spot configuration of hexagonal arrangement, confirming the formation of 60-degree-rotation inversion domains. It can be seen that the majority of Pt atoms exactly reside at the MTB to form a single chain. In addition, a small amount of dispersed Pt atoms are also observed in our sample, which is due to the filling of Pt atoms in native vacancies inevitably introduced during the CVD process^{22, 23}, to minimize the system energy. To probe the local environment surrounding the Pt atoms, we examined the blue rectangular region highlighted in Fig. 2a. It turns out that Pt atoms form an atomically coherent 1D channel at the twin boundary (60°) (Fig. 2b), which agrees well with the simulated results in Fig. 2c. The corresponding intensity profiles

along Pt SMACs indicate that the distance between adjacent Pt atoms is around 3.2 Å (Fig. 2d), much larger than the conventional Pt-Pt bonds, *i.e.*, 2.78 Å in the (111) plane^{24, 25}. The above observations suggest a unique structure of our highly ordered Pt single-atom-chain (see its detailed model within monolayer MoS₂ in Fig. 2e).

Geometric phase analysis (GPA) was also implemented on the ADF-STEM to draw the strain fields of these SMACs in Fig. 2f (see Methods section). The MoS₂ lattice parameter was selected as the reference. An apparent compressive strain around the two sides of the Pt SMAC is observed along the x-axis (ϵ_{xx} , the perpendicular direction to SMAC), but negligible along the y-axis (ϵ_{yy} , the parallel direction to Pt SMAC). We note that the ϵ_{xx} compressive strain is as high as $5.5 \pm 1.1\%$, indicating an effective uniaxial SMAC-localized in-plane strain.

To study the possible interlayer influence between Pt SMACs and MoS₂ layer, we examined the SMAC's structure in bilayer MoS₂. Upon applying the false-colour treatment on STEM images, the typical 3R and 2H stacking registries become distinguishable through the weak atom blobs in each honeycomb. As shown in Fig. 3a, Pt SMACs mainly present at a lateral 3R|2H|3R hybrid structure in bilayer MoS₂, which has a stacking sequence of AB|AA'|BA²⁶. Intriguingly, we found two types of Pt SMAC structures in bilayer MoS₂: Pt atoms in the bottom layer (Fig. 3b) and the top layer (Fig. 3c). The latter usually shows a brighter contrast than that of the former in the STEM imaging. The corresponding intensity profiles can be used to distinguish them (see right panels in Fig. 3b-c). We also applied GPA to probe the strain distribution around Pt SMACs in bilayer MoS₂ (Fig. 3d). It exhibits a phenomenon similar to that of monolayer MoS₂ (Fig. 2f), with a stronger compressive strain along the x-axis than that along the y-axis. Note that, in bilayer MoS₂, the formed strain around the Pt SMAC is significantly averaged in both the

bottom and top layers, thus exhibiting a weaker strain phase profile than that of the monolayer counterpart.

Formation mechanism. To elucidate the formation mechanism of Pt SMACs, we carried out the density functional theory (DFT) calculations (see details in Methods). First, by comparing the formation energy of a set of Pt-MoS₂ systems, we searched for the energy-optimal geometry for Pt atoms attached to the MoS₂ lattice. Among the enumerated structures, a four-coordinated motif (Pt-S₄), in which the single Pt atom covalently bond with 4 S atoms at the edge of MoS₂, gives the lowest binding energy (Supplementary Fig. 13). Such structure is also confirmed by our high-resolution characterization of the MoS₂ edge (Fig. 4a, bottom). Upon the chemisorption of several Pt atoms, we note that the energetically most favorable configuration is an ordered array of adjacent Pt-S₄ motifs at the MoS₂ terminal-end (Supplementary Fig. 14). Second, we explored the possible dynamical evolution of the adsorbed Pt atoms during the growth of a MoS₂ domain. In our calculations, MoS₂ units were added step-by-step to the Pt-terminated zigzag edge. At each step, various Pt attached sites were examined to ensure the optimal configuration (see configurational spectra at each growth step in Supplementary Fig. 16). These results indicate that the configurations that seamlessly extend the MoS₂ lattice are in low energy regions. The evolution of atomic configurations along the lowest energy pathway is presented in Fig. 4a, manifesting the flow of kinks along the Pt-passivated edge. In brief, the Pt-S₄ motif first evolves into a new kink hexagon (Fig. 4a ii) and later into a MoS₂ hexagon (Fig. 4a iii), which is also experimentally evidenced at a domain edge (Figure 4a, bottom). Later, the Continuous feeding of Mo and S atoms moves the kink to complete the growth of a new row, resulting in one-MoS₂ lattice-constant migration of the Pt-terminated edge along the growth direction (Fig. 4a vii). Therefore, we here call this dynamical evolution the "surfing" of Pt atoms, that is, the Pt-S₄ motifs will migrate to the growth front during the growing process.

Based on the above calculations, Pt atoms could "zip" them together by keeping the Pt-S₄ motifs, when two inversely oriented domains with similar Pt-termination connect laterally. This process yields a chain of Pt atoms covalently embedded in the MTB, namely, Pt SMAC (Fig. 4b). *Ab initio* molecular dynamics simulations suggest that the chain has excellent structural stability and can sustain an elevated temperature as high as 1000 K (Supplementary Fig. 19). We also studied the energy-optimized structure of Pt SMACs in a bilayer MoS₂ using MD simulations, showing that Pt SMACs are formed at the GBs between 2H and 3R phased bilayer MoS₂ (Supplementary Fig. 15), in good agreement with the atomic structure shown in Fig. 3b-c.

Metallic behaviour of Pt SMACs. The highly ordered Pt SMACs possess a larger interatomic distance than Pt metal (3.2 Å vs. 2.78 Å), determined by the host MoS₂ MTB. To examine the possible interaction in Pt SMACs, we further investigate the partial charge density distribution of Pt 5*d* orbitals (the inset of Fig. 4b). Apart from localized bonding electrons between S and Pt atoms, we also note substantial delocalized electron densities between adjacent Pt atoms, rendering SMACs as electronic transport channels. We then calculated the band structure and projected density of states (PDOS) of the SMACs, confirming the metallic behaviour (Fig. 5a and b, Supplementary Fig. 20, the red dot line) in sharp contrast to the scattered Pt atoms. This metallic behaviour is attributed to the substantial overlap of Pt electronic states, stemming from the Pt-Pt spacing less than 0.9 nm in our Pt SMACs. On the contrary, Pt atoms with a neighbour distance exceeding 1.5 nm (*e.g.*, single scattered Pt atoms) possess a highly localized defect band level, hindering the electronic transport (Supplementary Fig17). Electron localization function (ELF) further supports this result from the covalent interaction between Pt and S atoms (Supplementary Fig. 21) as well as electronic delocalization between Pt atoms along the chain (Fig. 5c). Moreover, charge transfer analysis between two stacked MoS₂ layers indicates that Pt

atoms in the top MoS₂ layer donate electrons to S atoms in the bottom MoS₂ layer (Fig. 5d), which is in good accordance with the two types of Pt (II) signals in the XPS spectra (Fig. 1c).

To verify this metallic behaviour of Pt SMACs, we fabricated a series of FET devices with channel lengths ranging from 2 μm down to 50 nm. The channel width kept constant at 1 μm (Fig. 5e and Supplementary Fig. 22). It is observed that the resistivity of the sample is around two orders of magnitude lower than that of CVD-grown MoS₂ (Fig. 5f, Supplementary Fig. 24).^{27, 28} Moreover, the resistivity exhibits an initial linear increase and later a critical transition from high to low value, demonstrating a volcanic relationship with the channel length (L). To further elaborate on this phenomenon, we adopt the complex-network-based method, a powerful tool for simulating carrier transport in nanostructured film²⁹⁻³¹, to investigate the electronic transport behaviour of Pt SMACs within MoS₂ film. The trend of the calculated resistivity shows a length dependence, well-consistent with the experimental results (Fig. 5h). Furthermore, the visualization of the current distribution confirms that carrier conduction proceeds by percolation through the Pt atomic chains for all length scales (Fig. 5g). Specifically, i) at shorter channel lengths (region 1), the termination of percolative pathways³² causes the increased resistivity; ii) at longer channel lengths (region 2), the high density of Y-shaped Pt SMACs junctions, which are formed due to the merging of MoS₂ grains, significantly enhances the conductivity of the channel (See Supplementary Note 2 for detailed discussion). Expectedly, our one-dimensional metallic chains can provide a model system to study interacting electrons, such as Tomonaga–Luttinger liquid and charge density waves³³⁻³⁶.

Conclusion

In summary, we developed a facile and effective chemical vapor co-deposition strategy to fabricate a wafer-scale network of Pt SMACs with remarkable stability. The atomic structures

and electronic properties of Pt SMACs were extensively studied in monolayer and bilayer MoS₂ films. Combining DFT analysis with experimental results, we proposed a "surf-zip" growth mechanism to reveal the growth process of Pt SMACs, and later successfully extended to grow Co SMACs via our co-deposition method (Supplementary Fig. 18). Moreover, we found a metallic behaviour of Pt SMACs originated from the substantial overlap of Pt electronic states, which can facilitate the electronic conduction of atom-thin films via the percolation through SMAC networks. Finally, our work offers a promising route to fabricate air-stable SMACs on a large-scale, and provides one of the smallest one-dimensional platforms for studying Luttinger liquids, the Fermi-liquid microscopic model, and other theoretical 1D models.

Methods

Synthesis of wafer-scale Pt SMACs inside MoS₂ films. 1) The Pt films were deposited on clean SiO₂/Si or sapphire wafers using e-beam evaporation with a speed of 0.1 Å s⁻¹ for 10 s. 2) The as-prepared Pt-coated SiO₂/Si wafers were used as the substrates for the chemical vapor deposition (CVD) of MoS₂ films (Supplementary Fig. 3). To be more precise, the substrates were placed facing down on an aluminum oxide boat containing MoO₃ powders in the middle of a quartz tube reaction chamber, and sulfur powders were loaded in another crucible upstream in the tube. 3) After purging the CVD system by 500 standard cubic centimetres per minute (sccm) argon flow for 3 min, the center of the furnace was heated from room temperature to growth temperature with a ramp of ~50 °C min⁻¹ under continuous argon gas of 60 sccm. The Pt SMACs inside MoS₂ films were synthesized by keeping the temperature of Mo sources at 650 °C for 4 mins, while S sources at around 230 °C. 4) The furnace was naturally cooled down under the protective argon atmosphere.

Material characterization Raman spectra were collected on a Renishaw inVia microscope under 532 nm laser at room temperature. The spot size is about 1 µm in diameter. The chemical states of obtained samples were analyzed by X-ray photoelectron spectroscopy (Kratos AXIS Supra XPS with a monochromatic Al-Kα source). Peak positions were all corrected by the C 1s spectrum at 284.8 eV.

STEM-ADF imaging and analysis. The as-prepared samples on the SiO₂/Si or sapphire wafers were transferred to the TEM grid for the STEM characterizations with the mediator of polymethyl methacrylate (PMMA). To avoid the hydrocarbon contamination during electron microscopy studies, all the TEM samples were baked at 200 °C for 8 hours under vacuum before the microscopy experiment. And ADF-STEM imaging and EDS mapping were conducted using

an aberration-corrected FEI ChemiSTEM operated at 200 kV with an approximately 20 pA probe current. The high signal-to-noise ratio ADF-STEM images are obtained by an image series composed of thirty fast exposure images of the same region followed by a post-acquisition image distortion correction and averaging, in which each pixel time was fixed at less than 6 μ s to avoid the significant beam damage. The ADF-STEM signal was collected at an angle range of 46-200 mrad with an electron beam convergence angle of 24.7 mrad. The occupied sites by Pt atoms were confirmed by comparing the experimental ADF-STEM images and simulated results. The simulation of the ADF-STEM images was performed with the Dr. Probe package³⁷, and the simulated parameters were fixed based on the experimental conditions. The strain analysis was performed with the geometric phase analysis (GPA) method using a dedicated script for DigitalMicrograph software, in which the strain was calculated with the reference of a perfect MoS₂ lattice.

Device fabrication E-beam lithography (EBL) was used to define a rectangular channel region (2 μ m x 150 μ m) of Pt SMAC/MoS₂ film on SiO₂/Si substrate. The rest Pt SMAC/MoS₂ film was etched away by CHF₃ plasma at -20°C for 40 s. Ti/Au (5 nm/20 nm) electrodes were defined by the EBL process followed by the e-beam evaporation and lift-off process.

Electrical characterization An Agilent B1500A semiconductor device parameter analyzer was used to examine the transport properties at room temperature in a vacuum chamber of 10⁻² Torr. Standard DC sweeps are carried out to evaluate the transfer characteristics of all devices.

Ab initio molecular dynamic (MD) simulations for Pt SMACs in ML MoS₂ In this model, the edges are passivated with S atoms. The related calculations were mainly implemented in the Vienna Ab initio Simulation Package (VASP)³⁸⁻⁴⁰, using spin-polarized density functional theory (DFT) based on the generalized gradient approximation (GGA) of the Perdew–Burke–Ernzerhof

(PBE) functional⁴¹. The core region was described by a projector augmented wave method with a plane-wave kinetic energy cutoff of 500 eV. The vacuum region was set to 15 Å to isolate neighboring periodic images. The Brillouin zone was sampled with a $(1 \times 20 \times 1)$ k -point mesh for geometry optimizations, while a $(1 \times 30 \times 1)$ mesh was used for electronic structure calculations. The self-consistency convergence criteria for the total energies were set to 10^{-6} eV, and all atomic positions and cell shapes were optimized using the Gaussian smearing method until the force component on each atom is below 0.01 eV Å⁻¹. The valences of Mo, S, and Pt were set to 6, 6, and 10, respectively. After structural optimization, the Pt atoms reside in the mirror twin boundary coordinated by 4 adjacent S atoms. The interatomic distance in the chain is 3.19Å. This is very close to the experimental value (3.15Å). For electronic structure calculation, we performed an electronic self-consistent field procedure with tetrahedron method using Blöchl corrections. The thermal stability of Pt SMAC in MoS₂ structure was evaluated by an *ab initio* molecular dynamic simulation using NVT ensemble. The simulation was run at 1000K, and the time step was set to 1fs over 30 ps.

Formation mechanism calculations

The binding energy of a single Pt atom on monolayer MoS₂ To investigate the energy preferred configuration of a single Pt atom on monolayer MoS₂, we calculated the binding energy of Pt atom at different sites of MoS₂. The calculation formula of binding energy is

$$E_b = E_{MoS_2+Pt} - E_{MoS_2} - E_{Pt}$$

where E_{MoS_2+Pt} is the total energy of the system when Pt is adsorbed on MoS₂. E_{MoS_2} is the energy of MoS₂, and E_{Pt} is the energy of a single Pt atom.

Initial structure justification (DFT optimized stable Pt-S₄ configuration) To determine the most stable arrangement of Pt atoms on the MoS₂ edge, we selected 4 representative structures and calculated their average binding energy of Pt-S. The average binding energy is defined as

$$E_{b-aver} = (E_{MoS_2+nPt} - E_{MoS_2} - nE_{Pt})/n$$

Among them, E_{MoS_2+nPt} is the total energy of the system. E_{MoS_2} is the energy of MoS₂ and E_{Pt} is the energy of a single Pt atom, n is the number of Pt atoms.

Electronic properties calculations

Electron localization function (ELF) The local charge density ELF^{42, 43} was used to examine the localized characteristics of electrons. Its value is between 0 and 1. The upper limit value 1 means that the electron is completely localized, while 0 means that the electron is completely delocalized. We calculated the local charge density and plotted it. In Fig. 5c, blue represents 0, and red represents 1. It can be found that there is no bond between adjacent Pt atoms, and an electron distribution similar to a covalent bond is formed between S and Pt.

Charge density difference calculation Charge density difference map is generally plotted to view the redistribution of charges after the interaction. Through the calculation and analysis of differential charge density, it is possible to obtain the properties of charge movement and the direction of bonding polarization in the process of bonding and electronic coupling. The definition formula of differential charge density is:

$$\Delta\rho = \rho_{bilayer\ MoS_2} - \rho_{MoS_2-Pt\ layer} - \rho_{MoS_2\ layer}$$

where $\rho_{bilayer\ MoS_2}$ is the charge density of the entire system, $\rho_{MoS_2-Pt\ layer}$ is the charge density of the MoS₂-Pt layer, and $\rho_{MoS_2\ layer}$ is the charge density of the perfect MoS₂ layer. Fig.

5d indicates that charge transfer happens between the Pt atom in the 1st MoS₂ layer and S atoms in the 2nd MoS₂ layer.

Complex-network-based method A representative Pt SMAC inner MoS₂ film of dimension $L \times \frac{L}{2}$ is occupied by a uniformly generated random distribution of Pt SMACs and line defects, and the background MoS₂, as shown in Supplementary Fig. 25b. Widthless Pt SMACs were randomly dispersed in the simulation film with an area density of about 9.4%. We used randomly generated coordinates (x_{Pt}, y_{Pt}) as the center of a Pt SMAC (Note that $0 < x_{Pt} < L, 0 < y_{Pt} < \frac{L}{2}$). Based on our STEM images, we imposed 3-fold symmetry with random overlap for Pt SMACs. Similarly, the line defects were randomly dispersed in the film with an area density of about 10.3%. Random coordinates (x_{defect}, y_{defect}) established the center of the defects and random angle θ with respect to the horizontal direction for its orientation. Then, the generated Pt SMACs inner MoS₂ film was converted into a complex network graph by a universal discretization approach²⁹. We assumed line defects as insulators with infinite resistance, background MoS₂ as resistors with resistance 1000 times larger than Pt SMACs. Then we converted the model into a resistor network and implemented the network by Matlab. By solving Kirchhoff's current law and Ohm's law, we calculated the overall resistance and the distribution of current.

Data availability

All data are available in the main text or supplementary materials.

Code availability

The code of the complex-network-based method employed in this work is available at <https://doi.org/10.6084/m9.figshare.c.4879863>.

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Author contributions

Z.L. and Y.H. guided the project. S.G. and Y.H. synthesized the Pt SMACs. S.G. conducted electronic measurements. J.F. and C.Z. (NTU, SEU) conducted the STEM characterizations. Z.Z. proposed "surf-zip" model. P.Z. and Z.Z. performed the first-principle calculations and analyzed the simulation data. H.Y., M.H., Y.H., and M.N. simulated electronic transport. Z.L., Y.H., Z.Z.,

and C.J. conceived and supervised the experiments. All the authors discussed the results and commented on the manuscript.

Competing interests

We declare no competing financial interests.

Figure Legends/Captions

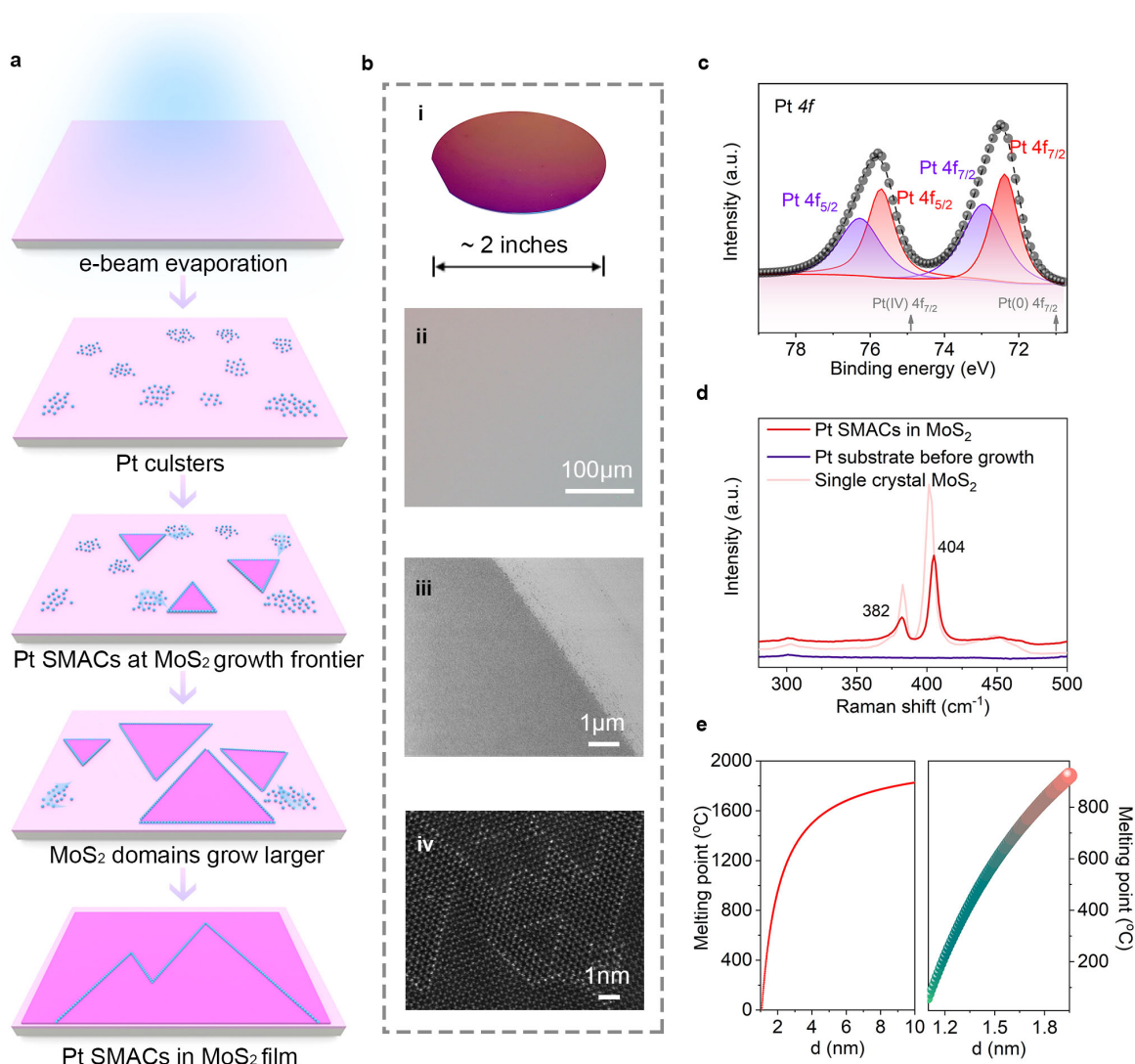


Fig. 1 Growth of Pt SMACs. (a) Schematic of the fabrication process with two typical steps: (i) high-density Pt atom-clusters were deposited on a SiO₂/Si substrate by e-beam evaporation at a rate of 0.1 Å s⁻¹, and (ii) Pt SMACs were formed during the growth of MoS₂ films. (b) Pt

SMACs/MoS₂ film from wafer-scale to nanoscale, including photograph (i), optical image (ii), SEM image (iii), and atomically resolved ADF-STEM image (iv). The bright dotted lines in (iv) show the contrast of Pt SMACs, and no massive Pt particle is observed in the MoS₂ nanograin film. (c) Pt 4f XPS spectra of as-grown film, in which two pairs of peaks were deconvoluted at 72.38, 75.71, 72.94, and 76.28 eV, attributed to the first type of Pt(II) 4f_{7/2}, the first type of Pt(II) 4f_{5/2}, the second type of Pt(II) 4f_{7/2}, and the second type of Pt(II) 4f_{5/2}, respectively. Grey arrows mark out the location of Pt(0) and Pt(IV). The scatter plot results from fitting the raw data (dashed black line). (d) Raman spectra of samples before and after MoS₂ nanograin film growth, and CVD-grown single-crystal MoS₂. (e) Left panel, the relationship between the melting point and the diameter for Pt nanoparticles. Right panel, the zoom-in illustration of melting states for clusters with diameter ≤ 2 nm at 650 °C (melted drops in blue and un-melted clusters in red). The clusters with a diameter smaller than 1.56 nm will melt at 650 °C.

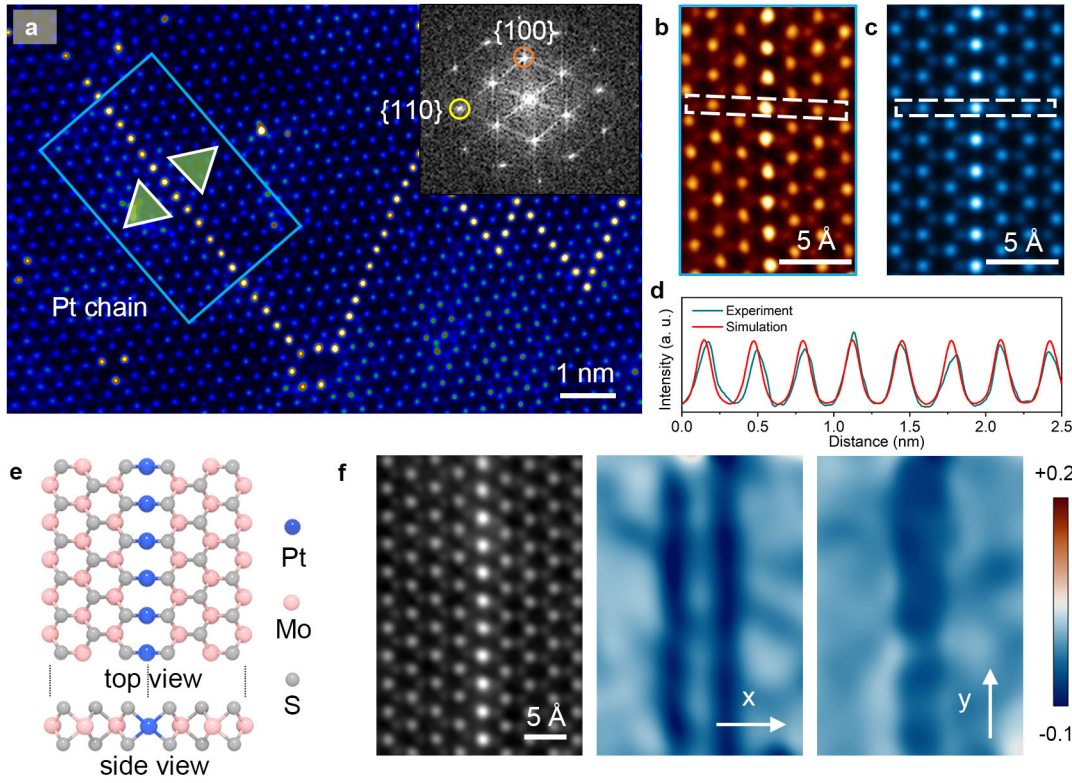


Fig. 2 Atomic structure of Pt SMACs in monolayer MoS₂. (a) False-coloured ADF-STEM image of Pt SMACs in monolayer MoS₂. Inset: Fast Fourier transformation (FFT) of the blue rectangular area. (b) Magnified ADF-STEM image of a single Pt chain obtained from the blue rectangular in Fig. 2a. (c) Simulated ADF-STEM imaging of a Pt chain. (d) Intensity profiles of the experimental and simulated images along the Pt SMACs. The average interatomic distance in the chain is measured as 3.2 Å. (e) Schematic of the detailed atomic structure of the Pt SMAC in monolayer MoS₂. (f) Left panel: magnified ADF-STEM image of a Pt SMAC in monolayer MoS₂. Strain mapping of the left panel with uniaxial strain components ϵ_{xx} (middle panel) and ϵ_{yy} (right panel), obtained by geometric phase analysis (GPA).

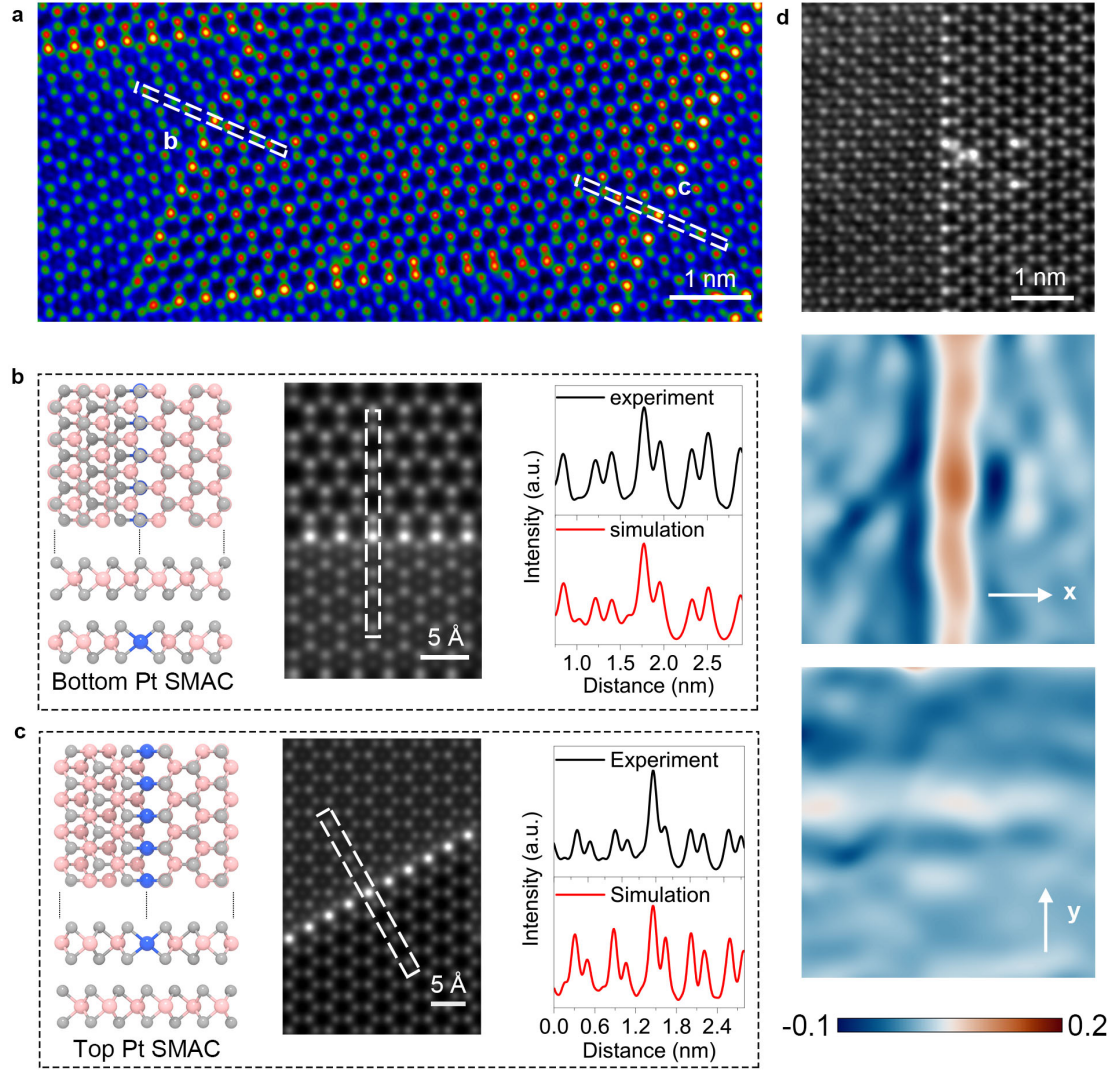


Fig. 3 Atomic structure of Pt SMACs in bilayer MoS₂. (a) False-colored ADF-STEM image of a bilayer MoS₂ region. (b) Atomic structure of Pt SMACs in the bottom layer of MoS₂, as shown with structural schematic (left), simulated STEM image (middle), and intensity profiles (right) along the white dashed box in Fig. 3a and the corresponding simulated STEM image. (c) Atomic structure of Pt SMACs in the top layer of MoS₂, as shown with structural schematic (left), simulated STEM image (middle), and intensity profiles (right) along the white dashed box in Fig. 3a and the corresponding simulated STEM image. (d) Top panel: magnified ADF-STEM image of a Pt SMAC in bilayer MoS₂. Strain mapping of the Pt SMAC in bilayer MoS₂, including ϵ_{xx} strain (middle) and ϵ_{yy} strain (bottom).

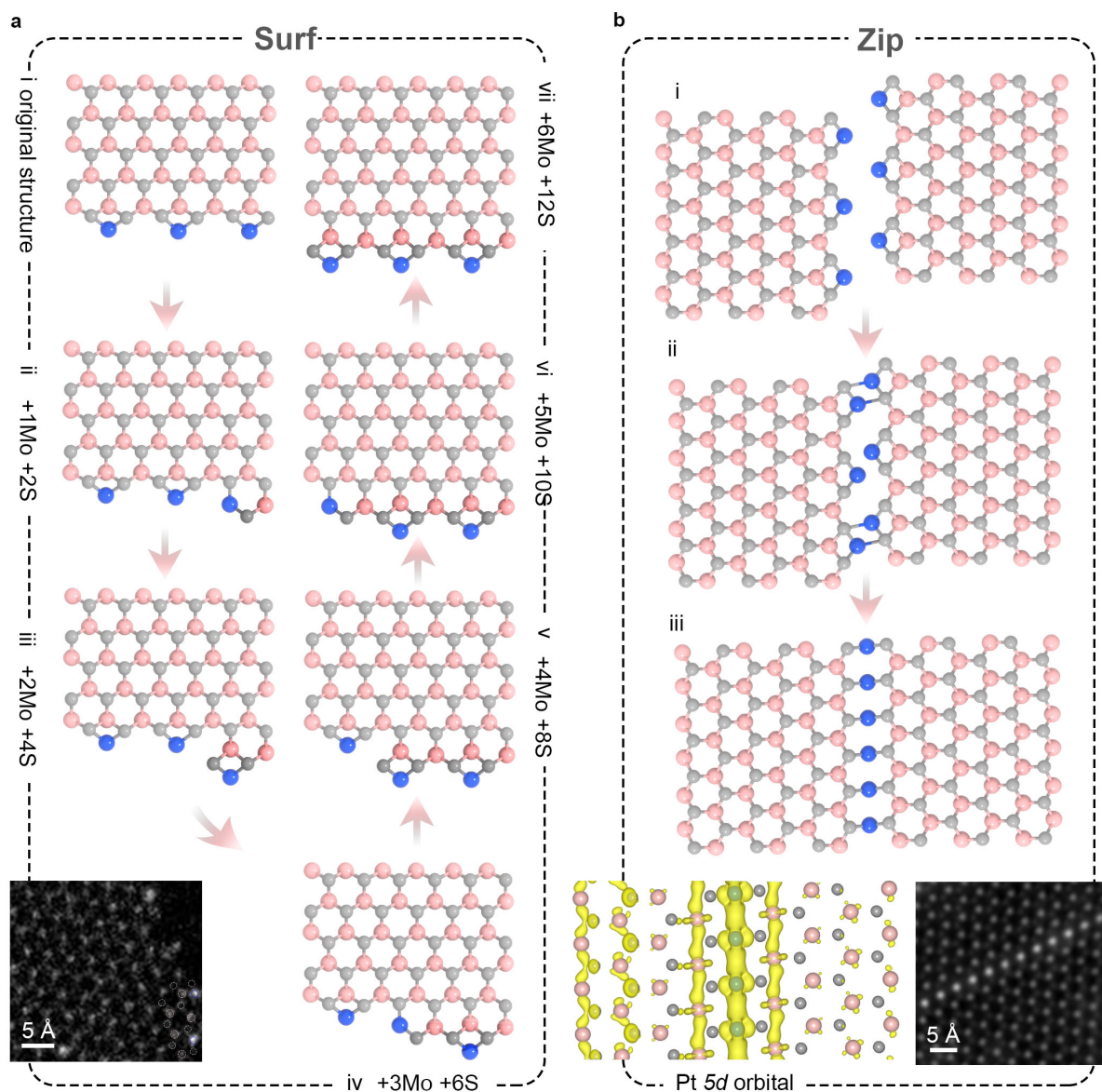


Fig. 4 Formation mechanism of Pt SMACs. (a) Energetically optimal atomic configurations i-vii during the step-by-step addition of MoS₂ units to a Pt-passivated zigzag edge. The feeding species for each step is Mo+2S. The growth leads to kink movement, shifting Pt atoms as if they surf along the growth front by coming feeding species. The bottom STEM image presents the evidence of the lowest energy intermediate state (iv). (b) The formation of Pt SMACs. Pt atoms along two zigzag edges zip together (ii, iii) when two inversely oriented Pt terminated MoS₂ domains meet each other. The STEM image corresponds to the formation of a complete Pt SMAC. The inset is isosurface plots (0.033776 e/Å³) of the partial charge density distribution of Pt 5d orbitals. A substantial overlap of electron densities between adjacent Pt atoms can be well-identified.

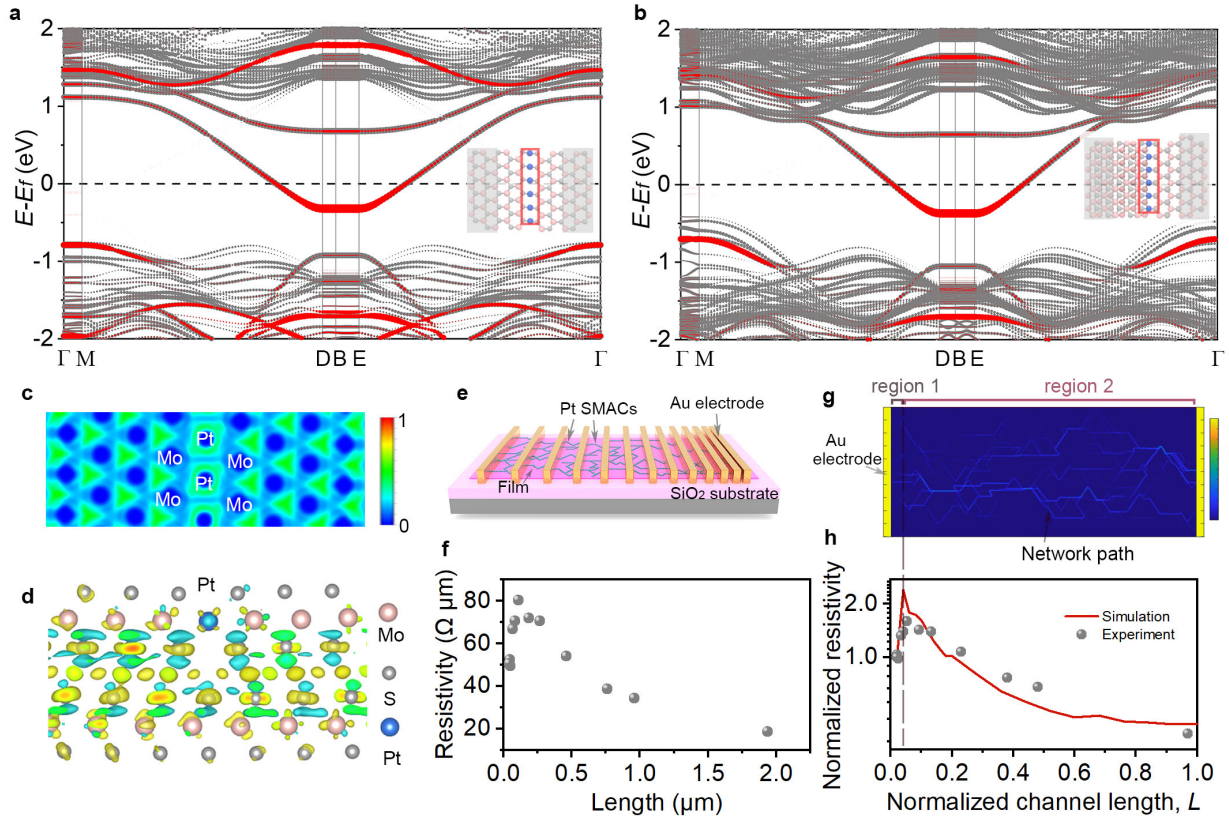


Fig. 5 Electronic structure of Pt SMAC. (a, b) Electronic band structures of a Pt SMAC embedded in a monolayer (a) and bilayer (b) MoS₂, respectively. The band structures are projected onto just the Pt atoms as well as those atoms in the bulk area (unshaded regions in the atomic structure). The weight character of bands is thickness encoded. Red lines mark the contribution of the Pt plus the S atoms directly bonded to them. The grey lines represent the whole Pt SMACs/MoS₂ system. (c) Electron localization function (ELF) map of Pt SMACs in a monolayer MoS₂ on the (001) plane. There is only weak electronic localization between adjacent Pt atoms. (d) Isosurface plot ($0.00016 e/\text{\AA}^3$) of charge density difference between a SMAC-containing MoS₂ layer and a pristine MoS₂ layer (side view). The charge accumulation and depletion regions are distinguished by yellow and blue, respectively. (e) Schematic illustration of transmission-line model (TLM) devices. The device structures with channel lengths from 2 μm to 50 nm are fabricated, and the channel width is defined to be 1 μm. (f) Room temperature resistivity as a function of channel length extracted using a typical two-terminal TLM. (g) Current color map calculated for the device with the largest channel length of L (normalized value of 1, corresponding to 2 μm in the experiment). (h) Normalized simulated resistivity and experimental results versus channel length.

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